TFW
PTO/SB/21 (04-04)

TRANSMITTAL FORM (to be used for all correspondence after initial filing)	Application Number	10/817,611
	Filing Date	April 2, 2004
	First Named Inventor	Sun, Sheng
	Art Unit	Not yet known
	Examiner Name	Not yet known
Total Number of Pages in This Submission	Attorney Docket Number	A7188/T47800

ENCLOSURES (Check all that apply)		
<input type="checkbox"/> Fee Transmittal Form <input type="checkbox"/> Fee Attached <input type="checkbox"/> Amendment/Reply <input type="checkbox"/> After Final <input type="checkbox"/> Affidavits/declaration(s) <input type="checkbox"/> Extension of Time Request <input type="checkbox"/> Express Abandonment Request <input checked="" type="checkbox"/> Information Disclosure Statement <input type="checkbox"/> Certified Copy of Priority Document(s) <input type="checkbox"/> Response to Missing Parts/Incomplete Application <input type="checkbox"/> Response to Missing Parts under 37 CFR 1.52 or 1.53	<input type="checkbox"/> Drawing(s) <input type="checkbox"/> Licensing-related Papers <input type="checkbox"/> Petition <input type="checkbox"/> Petition to Convert to a Provisional Application <input type="checkbox"/> Power of Attorney, Revocation Change of Correspondence Address <input type="checkbox"/> Terminal Disclaimer <input type="checkbox"/> Request for Refund <input type="checkbox"/> CD, Number of CD(s)	<input type="checkbox"/> After Allowance Communication to Technology Center (TC) <input type="checkbox"/> Appeal Communication to Board of Appeals and Interferences <input type="checkbox"/> Appeal Communication to TC (Appeal Notice, Brief, Reply Brief) <input type="checkbox"/> Proprietary Information <input type="checkbox"/> Status Letter <input checked="" type="checkbox"/> Other Enclosure(s) (please identify below): Return Postcard
Remarks The Commissioner is authorized to charge any additional fees to Deposit Account 20-1430.		
SIGNATURE OF APPLICANT, ATTORNEY, OR AGENT		
Firm or Individual name	Townsend and Townsend and Crew LLP Patrick M. Boucher Reg. No. 44,037	
Signature		
Date	July 22, 2004	

CERTIFICATE OF TRANSMISSION/MAILING			
I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on the date shown below.			
Typed or printed name	Nicole Wartell		
Signature		Date	July 22, 2004

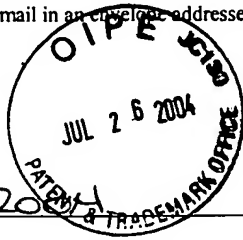
I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to:

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

On July 22, 2004

TOWNSEND and TOWNSEND and CREW LLP

By: Nicole Wartell
Nicole Wartell



PATENT
Attorney Docket No.: A7188/T47800
AMAT No.: AMAT No.
007188/DISPLAY/AKT/BG
TTC No.: 016301-047800US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Sheng Sun et al.

Application No.: 10/817,611

Filed: April 2, 2004

For: METHOD AND SYSTEM FOR
CONTROL OF PROCESSING
CONDITIONS IN PLASMA
PROCESSING SYSTEMS

Examiner: Not yet known

Art Unit: Not yet known

INFORMATION DISCLOSURE
STATEMENT UNDER 37 CFR §1.97 and
§1.98

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The references cited on attached form PTO/SB/08A are being called to the attention of the Examiner. U.S. patents are not enclosed in accordance with the Patent Office waiver issued August 5, 2003 in the Official Gazette, which states as follows:

The Office hereby waives the requirement under 37 CFR 1.98

(a)(2)(i) for submitting a copy of each cited U.S. patent and each U.S.

patent application publication for all U.S. national patent

applications filed after June 30, 2003 and for all international

applications that have entered the national stage under 35 USC 371

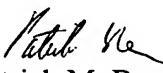
after June 30, 2003. See 37 CFR 1.491(b).

It is respectfully requested that the cited references be expressly considered during the prosecution of this application, and the references be made of record therein and appear among the "references cited" on any patent to issue therefrom.

As provided for by 37 CFR 1.97(g) and (h), no inference should be made that the information and references cited are prior art merely because they are in this statement and no representation is being made that a search has been conducted or that this statement encompasses all the possible relevant information.

Applicant believes that no fee is required for submission of this statement. However, if a fee is required, the Commissioner is authorized to deduct such fee from the undersigned's Deposit Account No. 20-1430. Please deduct any additional fees from, or credit any overpayment to, the above-noted Deposit Account.

Respectfully submitted,


Patrick M. Boucher
Reg. No. 44,037

TOWNSEND and TOWNSEND and CREW LLP
Two Embarcadero Center, Eighth Floor
San Francisco, California 94111-3834
Tel: 303-571-4000
Fax: 303-571-4321
PMB:nmb
60267257 v1



PTO/SB/08A (08-03)

Substitute for form 1449A/P INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)			Complete if Known	
			Application Number	10/817,611
			Filing Date	April 2, 2004
			First Named Inventor	Sun, Sheng
			Art Unit	Not yet known
			Examiner Name	Not yet known
Sheet 1	of 1	Attorney Docket Number	A7188/T47800	

U.S. PATENT DOCUMENTS+					
Examiner Initials*	Cite No. ¹	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number Kind Code ² (if known)			
	A1	US-5,200,023	04-06-1993	Gifford et al.	
	A2	US-5,271,264	12-21-1993	Chanayem	
	A3	US-5,467,883	11-21-1995	Frye et al.	
	A4	US-5,479,340	12-26-1995	Fox et al.	
	A5	US-5,578,161	11-26-1996	Auda	
	A6	US-5,653,894	08-05-1997	Ibbotson et al.	
	A7	US-5,737,496	04-07-1998	Frye et al.	
	A8	US-5,807,761	09-15-1998	Coronel et al.	
	A9	US-5,821,502	10-13-1998	Lukins et al.	
	A10	US-5,846,373	12-08-1998	Pirkle et al.	
	A11	US-5,910,011	06-08-1999	Cruse	
	A12	US-6,051,284	04-18-2000	Byrne et al.	
	A13	US-6,052,183	04-18-2000	Lee	
	A14	US-6,068,783	05-30-2000	Szetsen	
	A15	US-6,146,492	11-14-2000	Cho et al.	
	A16	US-6,160,621	12-12-2000	Perry et al.	
	A17	US-6,326,794 B1	12-04-2001	Lundquist et al.	
	A18	US-6,353,210 B1	03-05-2002	Norrbakhsh et al.	
	A19	US-2002/0055801 A1	05-09-2002	Reiss et al.	
	A20	US-6,413,867 B1	07-02-2002	Sarfaty et al.	

FOREIGN PATENT DOCUMENTS								
Examiner Initials*	Cite No. ¹	Foreign Patent Document			Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶
		Country Code ³	Number ⁴	Kind Code ⁵ (if known)				
	B1							<input type="checkbox"/>
	B2							<input type="checkbox"/>

Examiner Signature		Date Considered	
-----------------------	--	--------------------	--

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. ¹ Applicant's unique citation designation number (optional). ² Kind Codes of U.S. Patent Documents at www.uspto.gov or MPEP 901.04. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.
60267257 v1